



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 8585**  
Takashi OHSAKO et al. : Attorney Docket No. 2003\_1364A  
Serial No. 10/677,221 : Group Art Unit 2823  
Filed October 3, 2003 : Examiner Joannie Garcia  
METHOD OF MANUFACTURING : **Mail Stop: Amendment**  
SEMICONDUCTOR ELEMENT

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of  
October 31, 2006.

The fee of \$120.00 is

☒ (X) submitted herewith.

☐ ( ) to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is  
enclosed.

☐ ( ) Small entity status of this application is established by a Small Entity Status Assertion  
which

☐ ( ) is enclosed.

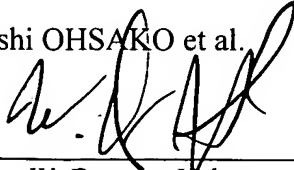
☐ ( ) has been previously submitted.

Respectfully submitted,

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

Takashi OHSAKO et al.

By

  
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February 28, 2007

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